



Receipt #8

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Eiji NATORI

Application No.: 09/819,688

Docket No.: 109120

Filed: March 29, 2001

For: METHOD AND DEVICE FOR MANUFACTURING CERAMICS,  
SEMICONDUCTOR DEVICE AND PIEZOELECTRIC DEVICE

**REQUEST FOR CORRECTION OF PALM RECORDS**

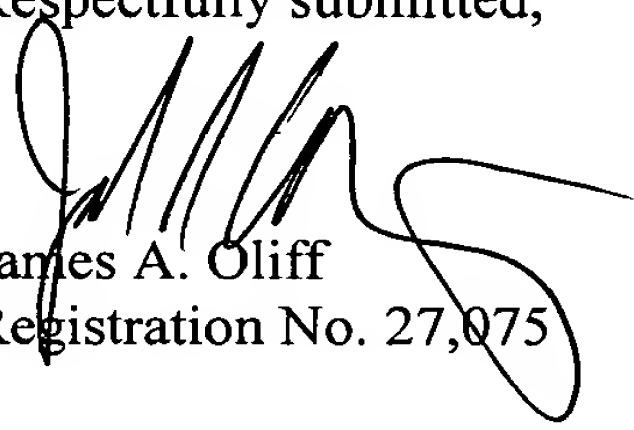
Director of the U.S. Patent and Trademark Office  
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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Attached is a copy of the PTO date-stamped postcard to confirm the filing date of March 29, 2001.

Respectfully submitted,

  
James A. Oliff  
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Date: October 12, 2001

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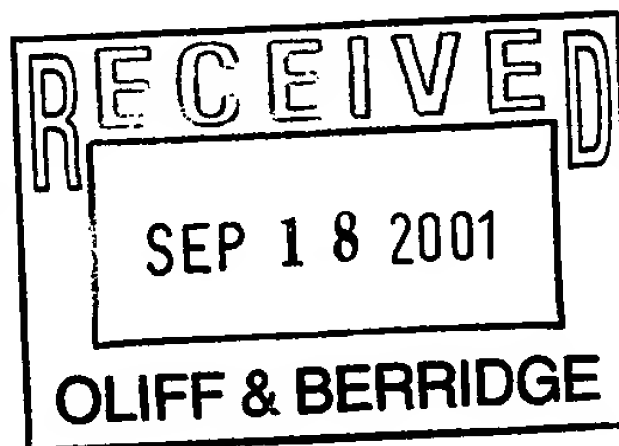
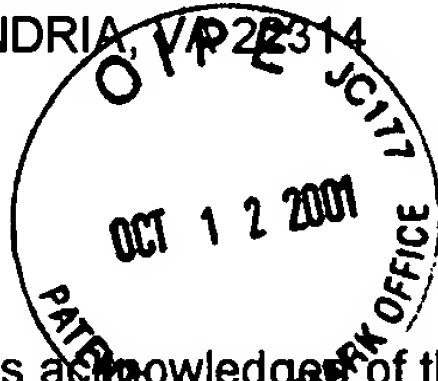
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/819,688	07/19/2001 03/29/2001	1731	1204	109120	3	33	2

25944  
OLIFF & BERRIDGE, PLC  
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CONFIRMATION NO. 3149

UPDATED FILING RECEIPT



\*OC000000006565359\*

Date Mailed: 09/17/2001

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**Applicant(s)**

Eiji Natori, Chino-shi, JAPAN;

**Assignment For Published Patent Application**

SEIKO EPSON CORPORATION;

**Domestic Priority data as claimed by applicant****Foreign Applications**

JAPAN 2000-91604 03/29/2000

If Required, Foreign Filing License Granted 05/25/2001

Projected Publication Date: 12/27/2001

Non-Publication Request: No

Early Publication Request: No

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**Title**

Method and device for manufacturing ceramics, semiconductor device and piezoelectric device

**Preliminary Class**

065